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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/757,252
Filing Date January 13, 2004
Inventor Denise M. Eppich et al.
Assignee Micron Technology, Inc.
Group Art Unit 1811
Examiner Unknown
Attorney's Docket No. MI22-2468
Title: CMOS Constructions and Capacitor Constructions

INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449

The citations listed may be material to the examination of the subject application and are therefore submitted in compliance with the duty of disclosure defined in 37 CFR §1.56. Copies of the cited art are included with the exception of U. S. patents and published U. S. applications (1276 Off. Gaz. Pat. Off., 05 August 2003). No admission is made regarding whether all the submitted references are prior art. The Examiner is requested to make these citations of official record in this application. No admission is made regarding whether all the submitted references are prior art.

The materials cited are presented to assist in and expedite examination of this application. The present invention is considered to be patentable over the cited materials. Expeditious examination and allowance of this application as a patent are therefore urged in order that the public may benefit from the disclosure and commercialization of the invention.

Citation of these references is respectfully requested.

Respectfully submitted,

Date:

10/4/04

By:



David G. Latwesen, Ph.D.
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